

<b>FORM 1449*</b> <b>THIRTY-EIGHTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT</b>			Docket Number: 60001.0244US01/300530.01	Application Number: 10/608,267
<b>IN AN APPLICATION</b>  (Use several sheets if necessary)			Applicant: Jeff Reynar et al.	
			Filing Date: June 27, 2003	Group Art Unit: 2178

<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	2004/0068694	04.2004	Kaler et al.	715	513	
	7,302,634	11.2007	Lucovsky et al.	715	200	
	6,898,604	05.2005	Ballinger et al.	707	101	
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	2004/0024875	02.2004	Horvitz et al.	709	226	
	2004/0002939	01.2004	Arora et al.	707	1	
	2003/0101190	05.2003	Horvitz et al.	707	100	
	2004/0044959	03.2004	Shanmugasundaram et al.	715	543-227	
	2004/0143581	07.2004	Bohannon et al.	707	100	
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<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES
	CA 2 246 920 A1	03.2000	Canada			
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, Etc.)						
		Polish Official Notice dated August 25, 2009 cited in Application No. P.365553/DP (60001.0216pl01)				
		Australian Official Action dated September 11, 2009 cited in Application No. 2003204478 (60001.0190au01)				
		Norwegian Official Action dated August 24, 2009 cited in Application No. 2003 2550 (60001.0181no01)				
		Polish Official Notice dated September 22, 2009 cited in Application No. P. 364854/DP (60001.0211pl01)				
		Polish Official Notice dated September 23, 2009 cited in Application No. P. 360520/DP (60001.0181pl01)				
		Korean Official Action dated September 30, 2009 cited in Application No. 10-2003-40988 (50037.0121ks01)				
		Japanese Official Notice of Final Rejection dated October 2, 2009 cited in Application No. 2003-162911 (60001.0181jp01)				



EXAMINER	DATE CONSIDERED
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.	

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<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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	6,591,260	07.2003	Schwarzhoff et al.	707	2	

**FOREIGN PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**




EXAMINER /Cesar B Paula/	DATE CONSIDERED 10/26/2009
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